

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : J. Keith Nelson
Serial No. : 10/526,949
Filing Date : March 8, 2005
For : Nanometric Composites as
Improved Dielectric Structures
Examiner : Jeffrey C. Mullis
Group Art Unit : 1796
Confirmation No. : 7560

5 Pages
Via EFS
Mail Stop Election
Attn: Examiner Mullis
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

ELECTION AND AMENDMENT

Sir:

In response to the Restriction Requirement dated January 2, 2008, please amend the
above-identified application as follows: